

Supporting Information

Activation of residual sodium via in-situ neutralization toward practical layered oxides

Xingjie Shao^{a,b, †}, Zhanhao Zhang^{a,b, †}, Xunmin Gu^{a,b}, Lei Ran^{a,b}, Yuchen Duan^{a,b}, Yubin

Niu^{a,b,}, Maowen Xu^{a,b,*}*

a. School of Materials and Energy, Southwest University, Chongqing 400715, PR China

b. Chongqing Key Laboratory of Battery Materials and Technologies, Chongqing 400715,

PR China

Email: niuyubin@swu.edu.cn (Yubin Niu)

Email: xumaowen@swu.edu.cn (Maowen Xu)

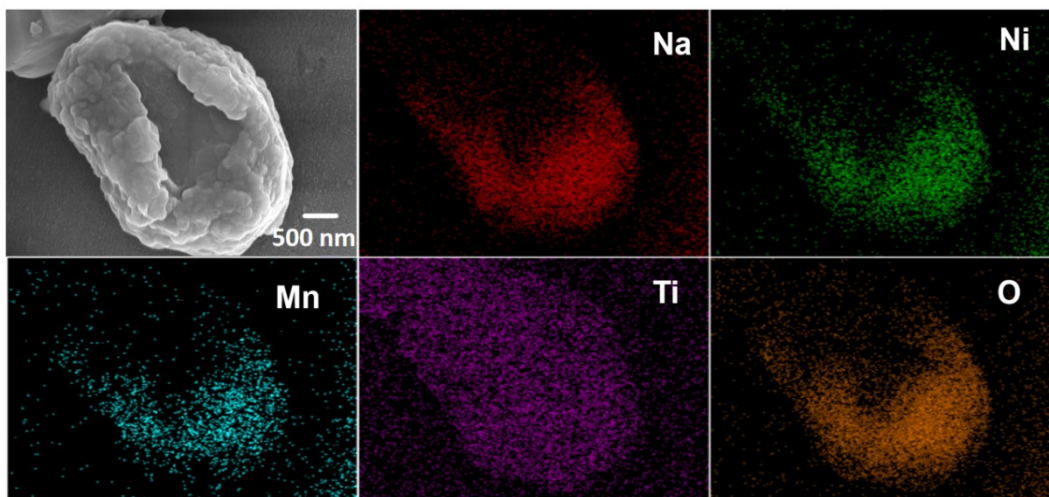


Figure. S1. EDS mapping images of P2-NMT.

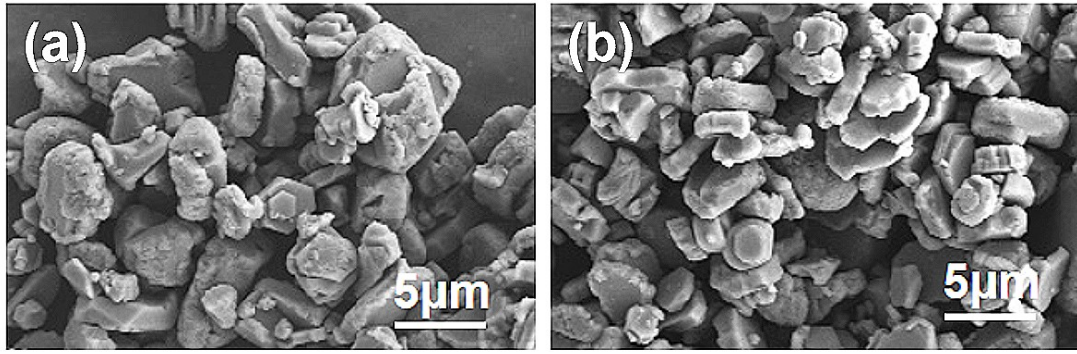


Figure. S2. SEM images of (a) NMT and (b) NMT@IDA.

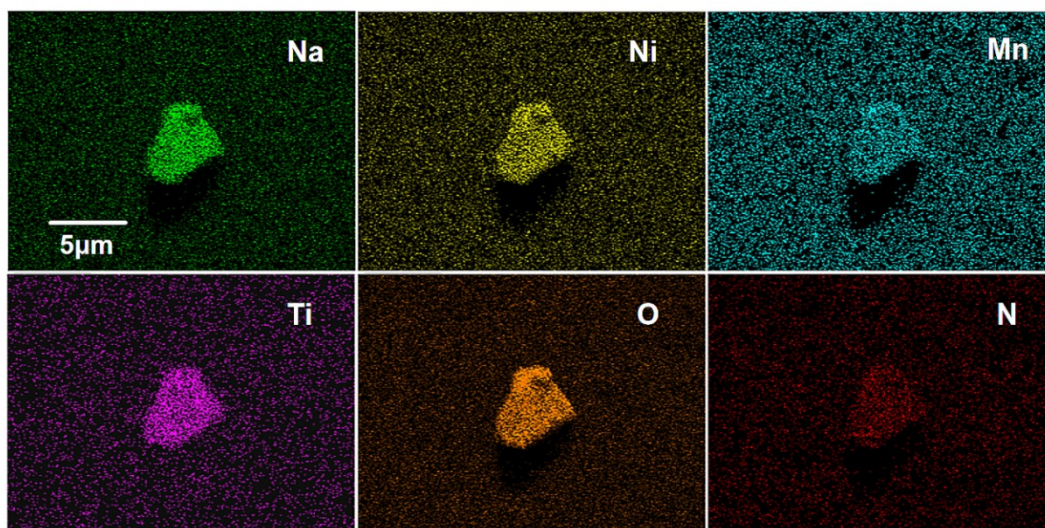


Figure. S3. EDS mapping images of P2-NMT@IDA.

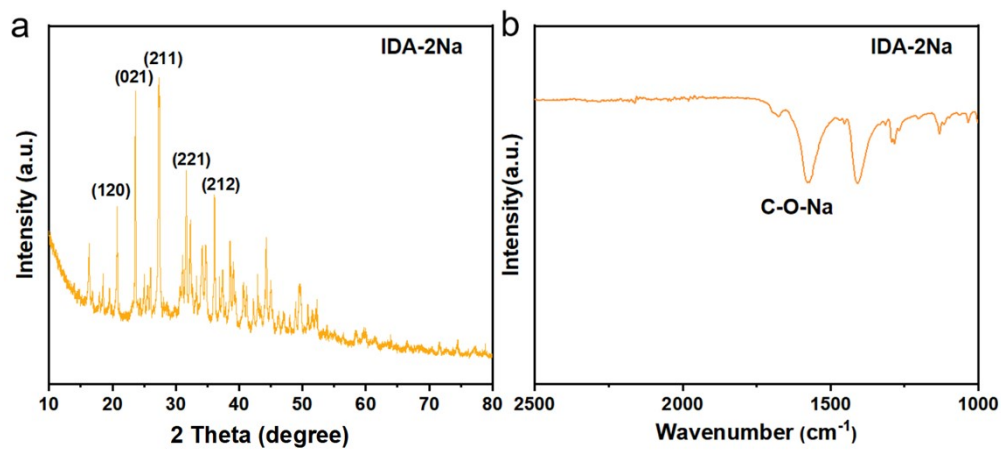


Figure. S4. (a) XRD patterns of IDA-2Na, (b) Fourier transform infrared spectroscopy (FTIR) patterns of IDA-2Na.

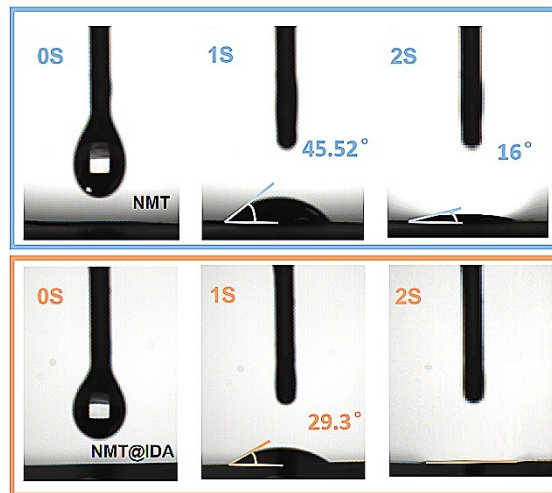


Figure. S5. The wetting snapshot of electrolyte droplets of (a) P2-NMT and (b) P2-NMT@IDA electrodes.

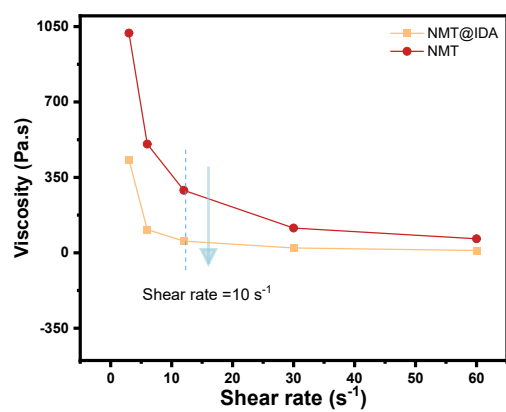


Figure. S6. Oscillatory shear rheology of the electrode slurry.

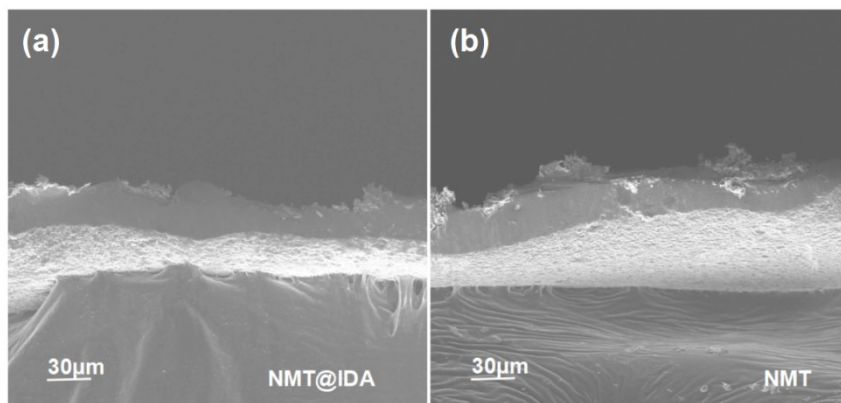


Figure. S7. SEM analyses for the morphology of (a) P2-NMT and (b) P2-NMT@IDA electrodes, in which show the cross-sectional images.

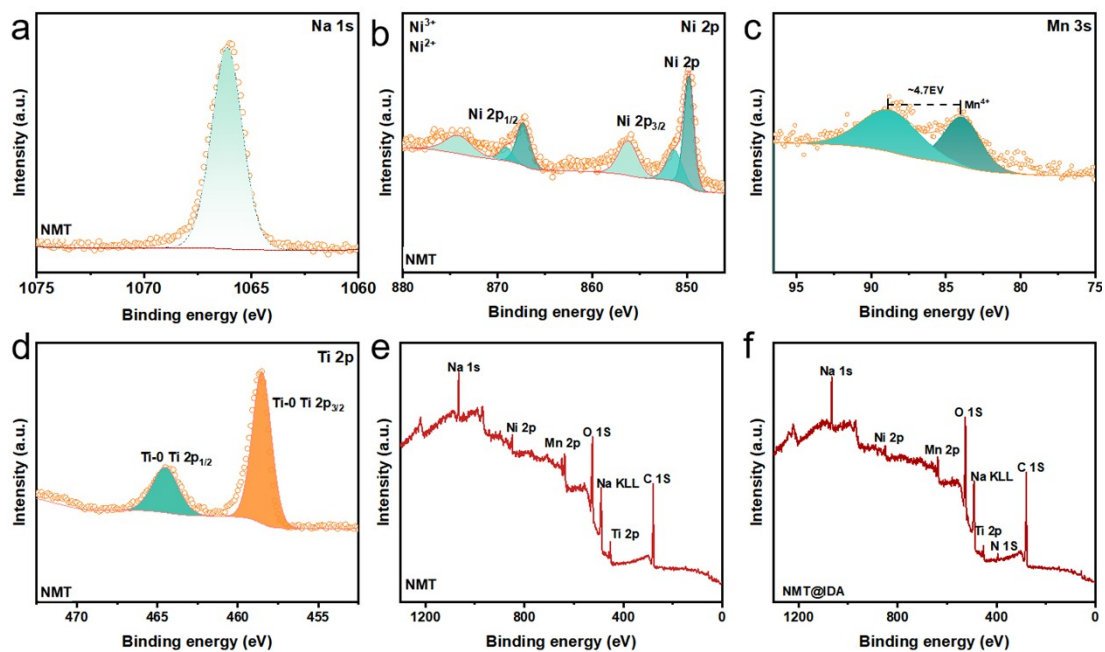


Figure. S8. High-resolution (a) Na 1s, (b) Ni 2p, (c) Mn 3s, (d) Ti 2p XPS spectrum of NMT sample. High-resolution (d-f) XPS full spectrum of NMT and NMT@IDA sample.

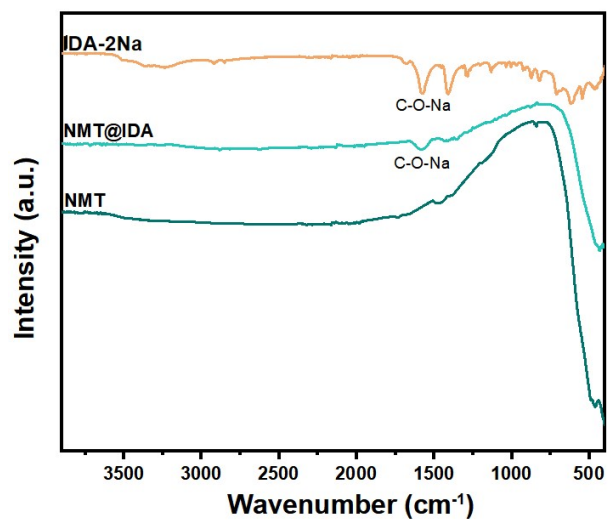


Figure. S9. FTIR spectra for P2-NMT, P2-NMT@IDA and IDA-2Na sample.

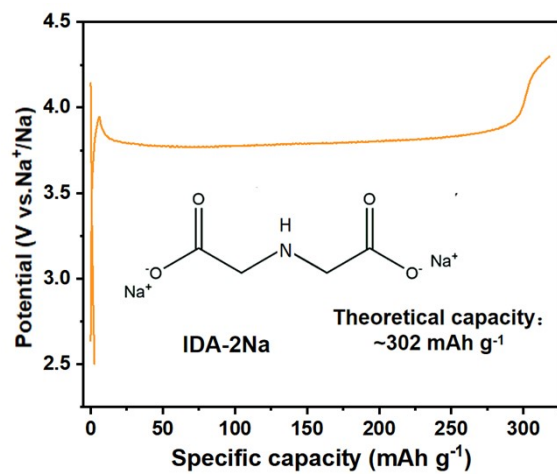


Figure. S10. Electrochemical properties of IDA-2Na at 0.1 C.

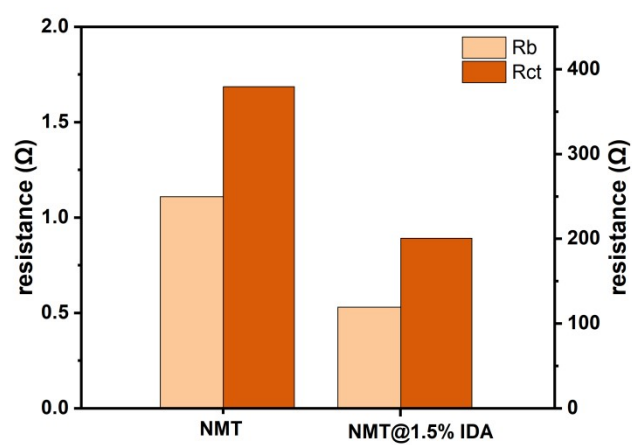


Figure. S11. The value of impedance parameters R_b and R_{ct} that received by fitting the Nyquist plots of P2-NMT and P2-NMT@IDA cathodes.

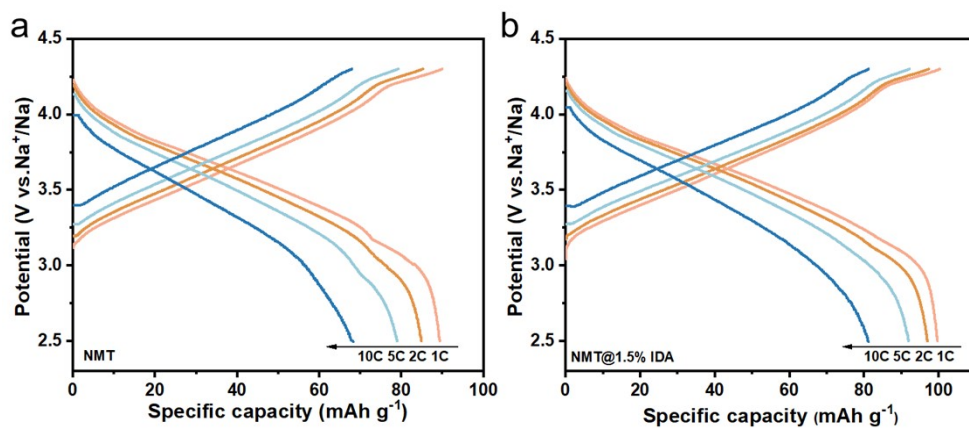


Figure. S12. The rate capabilities of P2-NMT and P2-NMT@IDA at different current densities. The charge/discharge curves of (a) P2-NMT||Na and (b) P2-NMT@IDA||Na cells at rates of 1, 2, 5, and 10 C.

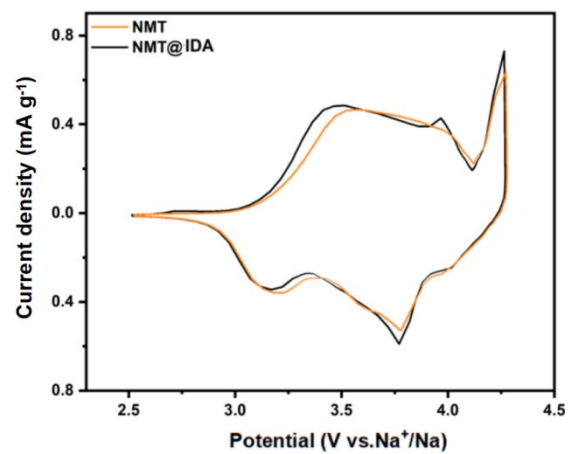


Figure. S13. CV curves of half-cells at 0.1 mV s⁻¹.

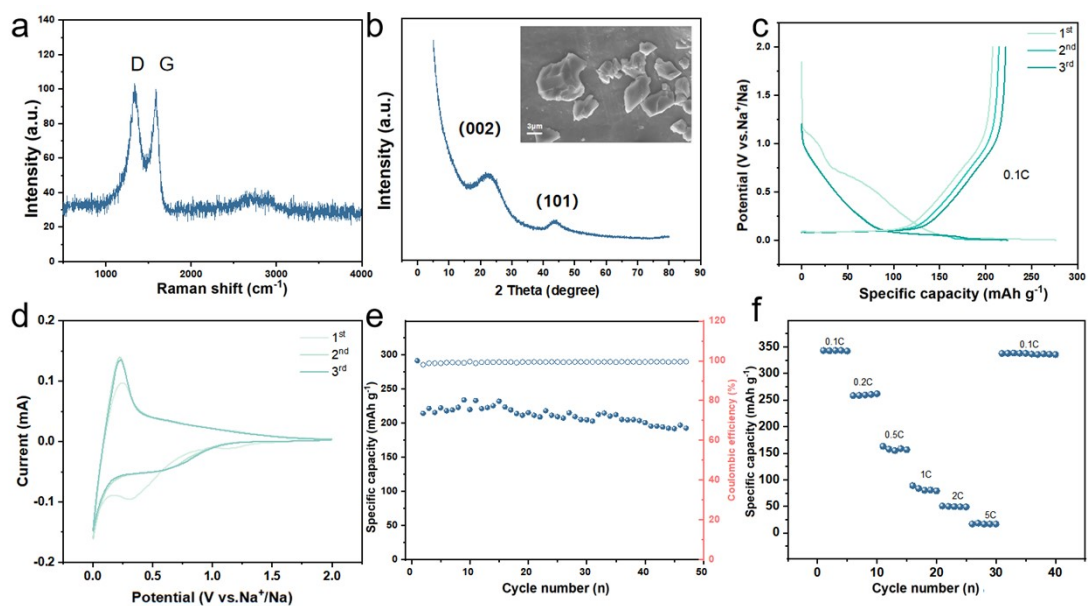


Figure. S14. Characterization of the structure and properties of hard carbon materials. (a) Raman spectrum. (b) SEM image and XRD pattern. (c) Charge and discharge profiles at 0.1 C in the voltage range of 0.01 to 2.0 V. (d) CV curves at 0.1 mV s⁻¹. (e) Cycle performance and (f) rate performance.

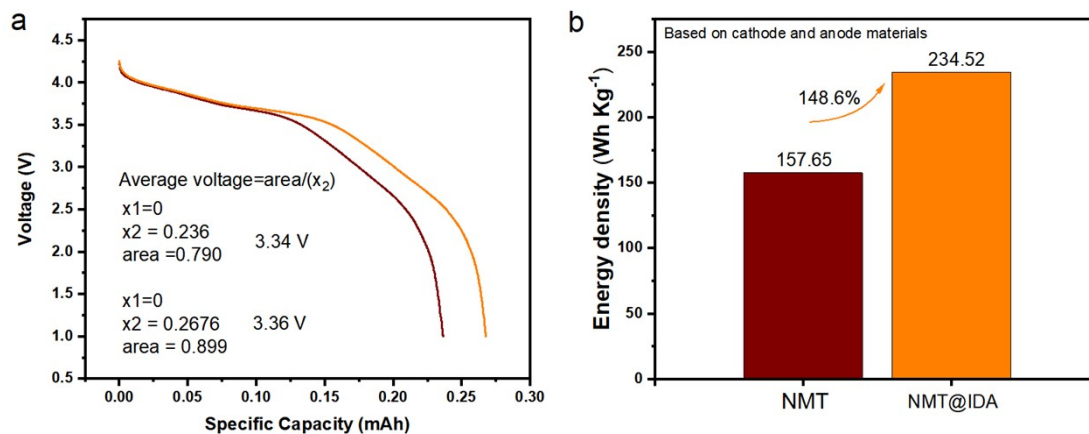


Figure S15. (a) Comparison of charge/discharge profiles energy density of NMT and NMT@IDA in full cells. (b) Integral results of the discharge profiles and the calculation of the corresponding average voltage.

Table S1. Lattice parameters of P2-NMT and P2-NMT@IDA samples.

Sample	a /Å	b /Å	c /Å	α	β	γ
$\text{Na}_{2/3}\text{Ni}_{1/3}\text{Mn}_{1/3}\text{Ti}_{1/3}\text{O}_2$	2.924025	2.924025	11.159918	90°	90°	120°
$\text{Na}_{2/3}\text{Ni}_{1/3}\text{Mn}_{1/3}\text{Ti}_{1/3}\text{O}_2\text{@IDA}$	2.924835	2.924835	11.162878	90°	90°	120°

Table S2. Rietveld refinement of XRD data for P2-NMT.
 NMT. Space group P63/mmc.
 $a=b=2.924025 \text{ \AA}$; $c=11.159918 \text{ \AA}$;
 $\alpha=\beta=90^\circ$; $\gamma=120^\circ$; $V=82.633 \text{ \AA}^3$.
 $R_{wp}=4.64\%$; $R_p=3.40\%$.

Atom	x	y	z	Occupancy
Na _f	0.00000	0.00000	0.25000	0.192
Na _e	0.33333	0.66667	0.75000	0.475
Mn	0.00000	0.00000	0.00000	0.333
Ni	0.00000	0.00000	0.00000	0.333
Ti	0.00000	0.00000	0.00000	0.333
O	0.33333	0.66667	0.08391	1.000

Table S3. Rietveld refinement of XRD data for P2-NMT@IDA.
NMT@IDA. Space group P63/mmc.
a=b=2.924835 Å; c=11.162878 Å;
 $\alpha=\beta=90^\circ$; $\gamma=120^\circ$; V=82.701 Å³.
R_{wp}=5.07%; R_p=3.64%;

Atom	x	y	z	Occupancy
Naf	0.00000	0.00000	0.25000	0.192
Nae	0.33333	0.66667	0.75000	0.475
Mn	0.00000	0.00000	0.00000	0.333
Ni	0.00000	0.00000	0.00000	0.333
Ti	0.00000	0.00000	0.00000	0.333
O	0.33333	0.66667	0.07980	1.000

Table S4. ICP-OES results for P2-NMT and P2-NMT@IDA.

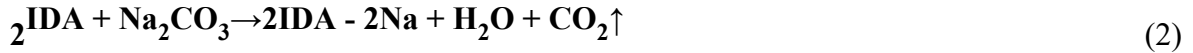
Sample	CHNS Weight (mg) by ICP-AES	Na (%) by ICP- AES	Ni (%) by ICP- AES	Ti (%) by ICP- AES
$\text{Na}_{2/3}\text{Ni}_{1/3}\text{Mn}_{1/3}\text{Ti}_{1/3}\text{O}_2$	11.3	13.9	19.62	14.6
$\text{Na}_{2/3}\text{Ni}_{1/3}\text{Mn}_{1/3}\text{Ti}_{1/3}\text{O}_2@IDA$	11.8	14.5	20.1	15.9

Table. S5 Quantitative analysis of surface residual alkali in the pristine NMT sample.

Sample	NaOH content (wt%)	Na ₂ CO ₃ content (wt%)
NMT	0.24 wt%	0.43 wt%

Note S1

In this work, calculation of Stoichiometric IDA Requirement can be calculated based on the following two equations:



Calculations of IDA Requirement are based on the equations.

The formula is:

$$\text{IDA (\%)} = \frac{133.10}{2 \times M_{\text{NaOH}}} \times \text{NaOH content (wt\%)} + \frac{2 \times 133.10}{M_{\text{Na}_2\text{CO}_3}} \times \text{Na}_2\text{CO}_3 \text{ content (wt\%)},$$

where M_{NaOH} and $M_{\text{Na}_2\text{CO}_3}$ are the relative molecular mass of NaOH and Na_2CO_3 , respectively.

Specific calculation process based on the Table. S4:

1. IDA required to neutralize NaOH

Molar mass: IDA = 133.10 g • mol⁻¹, NaOH = 40.00 g • mol⁻¹.

Stoichiometry: 1 mol IDA reacts with 2 mol NaOH.

Mass of IDA needed to neutralize 0.24 g NaOH per 100 g cathode:

$$133.10 \times 2 \times 0.24 \approx 0.40 \text{ g per } 100 \text{ g cathode} = 0.40 \text{ wt\%}$$

2. IDA required to neutralize Na₂CO₃

Molar mass: Na₂CO₃ = 105.99 g • mol⁻¹.

Stoichiometry: 2 mol IDA reacts with 1 mol Na₂CO₃.

Mass of IDA needed to neutralize 0.43 g Na₂CO₃ per 100 g cathode:

$$2 \times 133.10 \times 0.43 \approx 1.08 \text{ g per } 100 \text{ g cathode} = 1.08 \text{ wt\%}$$

3. Total IDA required for complete neutralization:

$$0.40 \text{ wt\%} + 1.08 \text{ wt\%} = 1.48 \text{ wt\%}$$

4. Practical application:

In the actual slurry environment, factors such as solubility of IDA in NMP, dispersion homogeneity, and surface accessibility may affect the reaction efficiency. A slight excess

(1.5 wt%) helps ensure complete neutralization and uniform coating formation.

Performance optimum: As shown in Fig. 4e-f, 1.5 wt% IDA delivered the best overall electrochemical performance, indicating that this loading balances complete alkali conversion with the formation of a functional interfacial layer without introducing excessive porosity or impedance.